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PULSED CHEMICAL LASER TECHNOLOGY DEVELOPMENT

TEST PLAN

SINGLE PULSE DIAGNOSTIC TESTING

Contract No. DAAHO1-83-C-0282

Prepared For
Department of the Army
U.S. Army Missile Command
Redstone Arsenal, Alabama

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Pulsed Chemical Laser Technology Development Program Test Plan Single Pulse Diagnostic Testing

1.0 INTRODUCTION

Single pulse DF and DF/CO₂ transfer laser testing will be conducted to expand the data base for verification and extension of performance scaling relations. Scaling relations are currently based on the analytical effort completed under Task I and the caparison of this analysis with available data.

Tests will explore the effects on performance of gas composition with constituents including F_2 , D_2 , O_2 , HF, NF_3 , He, N_2 , and CO_2 at both DF and CO_2 wavelengths. Tests will explore the nature of the gas medium in terms of F atom initiation level and gain, the nature of the initiating electron beam source in terms of energy deposition level and uniformity and pulse length, and laser yield in terms of total energy, pulse shape and time resolved spectra. The system will operate at pressures ranging from 200 to 760 torr.

The test plan is preceded by a detailed schedule for implementation of special diagnostics and repetitive pulse power as well as single pulse laser testing. This illustrates the timing of applications of special diagnostics and the availability of time for single pulse testing. Coordination of this with implementation of repetitive pulse power is crucial to the scheduled start of repetitive pulse laser testing in July 1984. Single pulse testing capability will be retained throughout the repetitive pulse testing period. This will allow continued laser testing even in the event of temporary down time for the repetitive pulse power system.

The first two single-pulse test intervals (total two weeks) are viewed as system shakedown and have been described in a letter to MICOM (J.M./Walters) dated 3/1/83. These tests are included in this document for completeness.

2.0 OVERALL EXPERIMENTAL PROGRAM

All elements of laboratory effort through to the start of repetitive pulse testing are listed in schedules of Table I (3 parts), Table II and Table III. Final system shakedown of all new gas handling will be completed 2/24/84. On-line fluorine system shakedown and laser optics installation will be completed 3/2/84. Diagnostics for F-atom production measurements will be installed in the same period.

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Laser performance shakedown will be conducted during the week of 3/5 - 3/9. This test will repeat a previous run with a composition of 20 percent F_2 , 6 percent D_2 , 1 percent D_2 . 73 percent He. Calorimetry and laser pulse shape data will be compared with earlier studies to verify the workability of the system after the extensive modifications completed under the current contract. The operational capability of the F-atom formation diagnostics will also be tested.

An improved E-beam cathode will be installed and tested during the week 3/12 - 3/16. This cathode as described in CDR will substantially improve efficiency of conveyance of electrons to the cavity. It will thereby improve electrical efficiency and reduce the power demand on the power supply system.

Laser performance shakedown with the new cathode will be conducted during the week 3/19 - 3/23. In this period, the operation of the jet pumps will be tested in combination with laser testing at subatmospheric pressures.

The test period proper begins 3/26/84. A two-week test period is indicated. During this time, the laser spectrometer will be installed and time integrated spectral measurements will be conducted. The parallel development of time resolved spectral measurements is shown in Table I. After this two-week test period, additional E-beam performance testing will be conducted in the week 4/9 -4/13.

Implementation of the repetitive pulse power system is shown in the schedule of Table II. Much of the construction is done as modular subassemblies. Certain of the components may be installed in the facility without disrupting laser testing. The period between 4/9 and 5/4/84 is to provide for installation and testing which may be disruptive to laser performance testing. During this period, the facility is dedicated to this effort although diagnostics implementation continues.

Laser performance testing will be conducted during the weeks 5/7 - 5/11 and 5/14 - 5/18. During this time, the F-atom production and the time resolved laser spectral diagnostics will be operational and will be implemented. Time resolved laser spectral measurements require a multichannel data acquisition system which will be implemented as shown ion the schedule of Table I.

The above laser measurements will address DF performance. Conversion to DF/CO $_2$ operation will be conducted during the week 5/21 - 5/25. Performance measurements for DF/CO $_2$ transfer laser operation will be conducted during the weeks 5/28 - 6/1 and 6/4 - 6/8. This will complete single-pulse laser performance testing, and the system will be converted for repetitive pulse testing.

Implementation of time dependent gain measurements is scheduled for completion in the week 4/30-5/4; however, the tight schedule shows only tentative testing in this single-pulse test period. It may be necessary to postpone these measurements until the repetitive pulse test period. The single-pulse Marx bank driver will be available and operational during the repetitive pulse test period. This will allow operation in this mode, should there be down time for the repetitive pulse power system.

Additional studies in PCL development, which are supported under IRAD funding are shown in Table III for completeness. These efforts address E-beam foil survival under PCL stress and thermal environmental conditions and the development of novel mechanical valving for DF laser applications. Their development does not impinge on single-pulse laser testing.

3.0 SINGLE PULSE DIAGNOSTICS TEST PLAN

3.1 DF Laser Performance Test Plan

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Shakedown testing during the week 3/5 - 3/9 (Table I) will duplicate operating conditions of a previous test series. This will reestablish operational capability after the extensive changes which have been made to the system under the current contract. This device baseline operation at 20 percent F_2 , 6 percent F_2 , 1 percent F_3 , 73 percent He yielded

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25 $J/(\hat{x})$ atm (DF) with outcoupling of 63 percent and a 100 cm gain length. Electron energy deposition was computed to be 4.1 J/\hat{x} , Scaling relations developed by Mirels predicted an initial F-atom production level of $F/F_2 = 0.13$ percent for this laser energy yield. Modeling by Physical Sciences Inc. predicted these same initiation/yield conditions when results were scaled on the basis of past comparisons with experiments. On this basis, the code was "anchored" to present device performance, and modeling tests were conducted. The principal guides to development of a test matrix are system capabilities, and the pursuit of operating conditions and performance which are predicted by the PSI modeling effort to be advantageous to Army applications.

Modeling results predict an improvement in baseline yield of 30 percent by decreasing the outcoupled fraction from 63 percent to 40 percent. Implementation of this change is not practical in the present experiment due to added laser optics alignment difficulties. It does, however, indicate a potential improvement in larger devices since the same benefit is obtained by increasing the gain length.

Laser performance with increasing initiation strength, i.e., electron energy deposition level, has been explored with this device for atmosphere pressure operation and with Helium diluent. These results were reported in the September 29th review and will not be duplicated in this test series. The

primary conclusion from these tests was that the laser yield increased with E-beam initiation strenth so long as the E-beam pulse length did not strongly overlap the laser pulse. On this basis, the current system will incorporate an new cathode design which will double energy delivered to the gas during a 0.5 usec pulse. After implementation, the laser energy yield will be measured during the week 3/19 - 3/23 under conditions otherwise identical to the baseline case described above. With electron beam characterization for both E-gun configurations, comparison of laser energy yield will provide a determination of the relationship between yield and initiation strength. F-atom production diagnostics will be implemented during these tests to provide a direct determination of initiation strengths.

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Since the F-atom production diagnostics measure HF concentration, the above tests will include a comparison of performance with minimum attainable HF concentration with that which is present in delivered Fluorine cylinders without cleanup. The tests of 3/19 - 3/23 will also examine laser yield as a function of cavity pressure. This will provide the first testing of jet pump operation in combination with laser performance testing.

The above tests are shown in the Test Matrix of Table IV. These will complete shakedown and allow commencement of the test series proper. Test elements listed in Table IV refer to laser performance measurements only. Electron beam testing and other testing is shown in Tables I, II, and III.

The effects of Helium diluent removal will be examined during the test period 3/26 - 4/6. This is of primary importance to Army applications where chemical pumping of all laser exhaust is required. It is also of interest in systems studies since modeling results predict no degradation in DF laser yield with He diluent removal. These predictions are based on constant concentration of stabilizing 0_2 at 0.01 atm. It is anticipated that 0_2 concentration will necessarily increase with decreasing He in the experiment to maintain stability. Since the requirements for minimum 0_2 must be determined experimentally, we anticipate two weeks will be required for these tests. One notes from previously reported modeling results that 0_2 has a dramatic negative impact on laser yield, hence its minimum stable concentration must be established for each level of He removal. The laser spectrometer will be installed during this test period in a configuration which will allow time integrated measurements.

Production of gaseous F_2 from solids by current techniques produces NF3 as a by-product. The ratio of NF3 to F_2 is to date 6/5, however, current studies indicate that this may ultimately be reduced to nearly zero. It is important to know the overall impact of NF3 presence on laser performance. It acts as a chain reaction terminator on the negative side but it acts as a stabilizer and as a source of F-atoms in E-beam pumped systems on the positive side. Modeling studies predict a degradation in laser yield of a factor of 0.77 when 0.24 atm of NF3 is added to a diluent free mix of

0.2 atm F₂, 0.06 atm D₂ 0.01 atm O₂. This compares with a degradation of 0.94 with equivalent N₂ dilution and no degradation with equivalent He dilution. These results are based on constant O₂ concentration and do not address the added F-atom yield from NF₃ or N₂. Test series 5/7 - 5/12/24 will address laser performance with NF₃ dilution from zero to 0.24 atm and with N₂ dilution from zero to 0.73 atm. Nitrogen dilution is of interest since further reduction in NF₃ yield from solids is attended by an increase in N₂ yield. The test matrix thus far addresses all the major issues associated with laser mixtures appropriate to Army applications. It is also of interest to explore other diluents such as SF₆ and Ar. These have not been included due to the tight test schedule. They will, however, be addressed ich the repetitive pulsed test period. Gain measurements diagnostics are scheduled to be installed during this period. Implementation will depend upon system availability in view of the competing scheduling of other diagnostics. If implementation is not practical here, it will be postponed to the repetitive pulse test period.

3.2 DF/CO2 Transfer Laser Test Plan

NO

Laser calorimetry and medium probing techniques must be changed for DF/CO₂ performance studies. The calorimeter will be placed inside the mirror box and medium probing will be done through small ZnSe windows. Spectral measurements will require a different grating in the spectrometer.

After modifications, DF/CO₂ transfer operation will be studied in the test period 5/28 - 6/8/84. DF/CO₂ transfer laser performance studies will begin with no diluent and explore the dependance of laser yield on CO₂ concentration. Modeling predicts optimum performance near CO₂:F₂ ~ 1:2 whereas Aerospace experiments were conducted with high ratios of CO₂:F₂. Efficient laser performance at low CO₂:F₂ ratios would have a favorable impact on system weight and size. After establishing optimum CO₂ concentration, the effect of NF₃ diluent will be explored. If one neglects absorption, modeling studies predict no degradation in energy yield with NF₃ addition. However, absorption by NF₃ may be an issue and must therefore be resolved.

4.0 SUMMARY

The test plan addresses all the major issues relevant to Army applications. The test laser is a flowing gas laser. It is currently configured for repetitive pulse operation with the exception of a pulse power system which will be incorporated in June, 1984. Since laser gas handling is nearly the same for single and for repetitive pulse operation, it is much more efficient to broaden the test matrix in the repetitive pulse mode. For example, laser yield vs D_2 concentration may be explored in a single run with a large number of data points simply by reducing D_2 flow rate continuously with time through the run in a known way. Dependance on concentration of other species may be explored similarly.

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BEP, PULSE 0E

> SPECTRA PULSE SHAP ENEBOA z_{oo}

ARTO392 NOITAITINI BULSE SHAPE DE : ENEBGA ELECTRIC, EF.F. **BVOR9MI**

PERFORMANCE AUCHOR

TEST DF LASER 10 ATM 20 F₂, 6 D₂, 10₂, 73 He
TEST DF LASER 0.5 ATM, 10 ATM, 20 F₂, 6 D₂, 1 O₂, 73 He
DF LASER PERFORMANCE MEASUREMENTS, COMPOSITE
CO₂ LASER PERFORMANCE MEASUREMENTS

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SINGLE PULSE ELECTRON BEAM
PUT CARBON FELT ON NEW CATHODE
TEST TRANSMISSION OF OLD CATHODE, 1/2-IN FOIL BAR SPACING
INSTALL NEW CATHODE
TEST NEW CATHODE TRANSMISSION, 1/2-IN FOIL BAR SPACING
TEST NEW CATHODE, FOIL BARS REMOVED

8 6 8 6 6 6

IIII

MAIN LASER OPTICS AND CALORIMETER
INSTALL LASER DOPTICS AND CALORIMETER
INSTALL LASER PULS E SHAPE DETECTOR
SHAKE DOWN CALORIMETER DIAGNOSTICS
SHAKE DOWN LASER ALIGNMENT OPTICS

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INSTALL F₂ SUPPLY GAS CLEANUP INSTALL HF.HCI PLUMBING SHAKE DOWN F₂ GAS HANDLING FLUORINE GAS HANDLING

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TABLE I: TEST PLAN TASK III - SINGLE PULSE TESTING

STATES OF STATES STATES STATES STATES STATES STATES

	2/20	2/27	2/20 2/27 3/5 3/12 3/19 3/26 4/2 4/9 4/16 4/23 4/30 5/7 5/14 5/21 5/28 6/4 6/11 6/1	3/12	3/19	3/26	4/2	\$	4,3	1/3	66/4	2/9	5/14	5/21	5/28	9/4	6/11	5
	2/24	3/2	3/9	3/16	3/23	3/30	4/6	4/13	6/2	4/27	5/4	11/9	2/24 3/2 3/9 3/16 3/23 3/30 4/6 4/13 4/20 4/27 5/4 5/11 5/18 5/25 6/1 6/8 6/15 6/2	5/5	· 9	8/9	6/15	8
LOW	Ī																	
INSTALL SINGLE PULSE FLUIDIC VALVE DRIVE																		
	İ	•																
TEST FULL FLOW pc - 10 ATM, 05 ATM		•																

5,7 8,7

/18

6/25 6/39

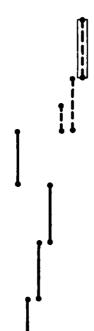
	FLUORINE ATOM PRODUCTION MEASUREMENTS FABRICATE F. ATOM OFFERENCE AND TEST LEGS SHARE DOWN LUMONICS DE LASER INSTALL FATOM CONVEYANCE OPTICS SHARE DOWN LUMONICS DE LASER MEASURE F. ATOM DETECTORS MEASURE F. ATOM DETECTORS MEASURE F. ATOM FORMATION TIME INTEGRATED LASER SPECTRAL MEASUREMENTS, DE TOWN CHANTER FABRICATE FILM HOLDER INSTALL FLASH LAMP INSTALL FLASH LAMP INSTALL ONE COMPLETE DE TA, 13 OH MEASURE LASER JD TA, 13 OH MEASURE DE (A, 13) CHANNEL INSTALL ONE COMPLETE DE TA, 13 OH MEASURE DE (A, 14) WITH DATA ACQUISITION MEASURE DE (A, 15) TIME RESOLVED SPECTRA MEASURE DE (A, 15) TIME RESOLVED SPECTRA DATA ACQUISITION SYSTEM MEASURE CO2 (A, 17) TIME RESOLVED SPECTRA MEASURE CO3 (A, 17) T	TABLE I: TEST PLAN: TASK III - SINGLE PULSE TESTING (Continued) 220 227 239 378 372 379 48 473 473 473 473 473 571 571 571 575 677 678 678 778 224 377 39 376 373 379 48 473 473 473 473 473 78 571 571 571 675 677 678 778	Ŷĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸĸ
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TABLE I: TEST PLAN: TASK III - SINGLE PULSE TESTING (Continued)

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33	3/	12 3/1	3/6	2/20 2/27 3/5 3/12 3/19 3/28 4/2 4/9 4/16 4/23 4/30 5/7 5/14 5/21 5/28 6/4 6/11 6/18 6/25 7/2	7	2	1,16	4/23	4/30	2/9	5/14	5/21	2/58	8/4	6/11	8/18	9/25	2/2
	<u></u>	3/2	는 교	2/24 3/2 3/9 3/16 3/23 3/30 4/6 4/13 4/20 4/27 6/4 6/11 6/18 5/25 6/1 6/8 6/16 6/22 6/29 7/8	8	13	8/3	4/27	\$/4	5/11	5/18	5/26	5	8/9	6/16	6/22	6/58	2%

- (TIME DEPENDENT GAIN MEASURMENTS, DF
 (1 INSTALL PROBE LASER GAS SUPPLIES
 (2 OBTAIN PROBE LASER LINE SELECTIVE OPTICS
 (3 ASSEMBLE LASER OPTICS
 (4 SHAKE DOWN FLASHLAMPS
 (5 INSTALL PROBE LASER CONVEYANCE OPTICS
 (6 SHAKE DOWN GAIN MEASUREMENT DETECTORS
 (7 MEASURE GAIN DF (A,1)



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TABLE II: TEST PLAN: TASK III - REPETITIVELY PULSED TESTING

5	2
\$/5	6/39
8/18	6/22
5	\$
3	9/9
5/28	5.5
12/9	\$/28
5/14	5
1/3	5.
85	5,4
4/23	4/27
4/16	4/20
\$	4/13
4,2	84
8 /6	3/30
3/19	3/23
2/20 2/27 3/5 3/7 3/79 3/79 4/7 4/7 4/78 4/20 6/7 6/74 6/21 6/28 6/4 6/11 6/18 6/75 7/2	2724 372 379 3716 3723 3/30 4/4 4/13 4/20 4/27 5/4 5/11 5/18 5/75 6/1 6/8 6/15 6/72 6/72 6/79 7/6
3,8	3/3
2/27	3/2
2/20	2/24

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- E-BEAM FOIL, REPETITIVE PULSE OPERATION
 MODIFY FOIL SUPPORT STRUCTURE FRAME
 FABRICATE FOIL SUPPORT BARS
 OBTAIN BACKUP 4 MIL KAPTON/10 MIL A FOIL
 TEST REW FOIL STRUCTURE TRANSMISSION, 3/8-IM, FOIL BAR SPACING
 TEST NEW FOIL STRUCTURE, BURST MODE REP PULSE

- M REPETITIVE PULSE POWER SYSTEM
 MI COUPLE DC POWER SUPPLY TO ENERGY STORAGE CAPACITORS
 MA ASSEMBLE CHARGING THYRATRON MODULE
 MA ASSEMBLE CHARGING REACTOR SYSTEM
 MA ASSEMBLE DISCHARGE THYRATRON MODULE
 MS ASSEMBLE INTERMEDATE SYDRAGE CAPACITOR SYSTEM
 MM INSTALL HV PULSE FRANSFORMER AND TRIGGER TRANSFORMER
 MS ASSEMBLE PULSE FORMING METWORK
 MS INSTALL MAIN SPARK GAP AND TRIGGER ISOLATION GAP
 MM INSTALL MAIN SPARK GAP AND TRIGGER ISOLATION GAP
 MNIOCOMPONENT CHECKOUT
 MILASSEMBLE SYSTEM CONTROL
 MILASSEMBLE SYSTEM CONTROL
 MILASSEMBLE SYSTEM CONTROL
 MILASSEMBLE SYSTEM CONTROLS WITH LASER SYSTEM CONTROLS
 MISINTEGRATE PPS CONTROLS WITH LASER SYSTEM CONTROLS
 MISINTEGRATE PPS CONTROLS WITH LASER SYSTEM CONTROLS
 MIGHISTALL COAXIAL CABLE COUPLING TO E-BEAM BUSHING
- N LASER PERFORMANCE MEASUREMENTS, REPETITIVE PULSE NI DF LASER PERFORMANCE N2 CO₂ LASER PERFORMANCE

TESTS START 6/30/84

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TABLE III: TEST PLAN: AERL-IRAD: REPETITIVELY PULSED TESTING

ANALES PARAMENTAL ACCORDENDE PRODUCTURA INCIDENCIA DE PRODUCTURA DE PROD

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\$ 58		
\$2/5 \$7.25		
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5 5		1
4/2 4/8 4/16 4/23 4/30 4/6 4/13 4/20 4/27 5/4		Ĭ
4727		
\$ \$	•	
\$ \$		
	.1	
3/28		Ш
3/23		
3/12		
3/2 3/8		
		11
72.70	1	
	O E-BEAM FOIL ENVIRONMENT SIMULATOR OI ASSEMBLE FLOW TRAIN O2 ASSEMBLE FLOW TRAIN O3 ASSEMBLE CAS SUPPLY AND CONTROL PLUMBING O3 BEENCH TEST FLUIDCY VALVES O4 ASSEMBLE VALVING AND MIXER O5 ASSEMBLE YALVING AND MIXER O6 FABRICATE FOIL SUPPORT STRUCTURE ASSEMBLY O7 INSTALL FLOW AND TEMPERATURE DIAGNOSTICS O9 SYSTEM SHAKE DOWN O9 TEST CANDHATE REP PULSE FOILS	P MECHANICAL D2 VALVING P1 COMPLETE VALVING DESIGN P2 DESIGN VALVE DRIVE TRAIN AND TIMING P3 FABRICATE VALVES P4 OBTAIN AND ASSEMBLE DRIVE TRAIN COMPONENTS P5 MODEY PC LGAS MANDLING TO ACCOMINGDATE VALVES P6 INSTALL MECHANICAL VALVES P7 TEST MECHANICAL VALVE

TABLE IV. TASK III SINGLE PULSE TESTING - TEST MATRIX

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SERIES DE	SERIES DESCRIPTION	PARAMETER	F2 % OR	% 2	6%	DILUENT %	<u></u>	% %	PRESSURE TORR.	INITIATION STRENGTH COUL/CM ²
3/5-3/9	SHAKE DOWN SYSTEM IMPLEMENT F.ATOM DIAGNOSTICS	න <u>්</u>	50	ဖ	-	He 73	MIN. VS. SUPPLIED	0	092	1.5
3/19-3/23	SHAKE DOWN SYSTEM WITH CATHODE MODIFICATIONS		50	ဖ	-	He 73	Ä.	0	200.760	1.5-3.0
3/26-4/6	LASER PARAMETRICS He REMOVAL IMPLEMENT TIME INTEGRATED SPE	REMOVAL	0.20	90.0	AS REQUIRED	He-0.73	MIN.	0	210.760	3.0
5/7-5/18	LASER PARAMETRICS ALTERNATE DILUENTS	ATE DILUENTS	0.20	90.0	AS	N ₂ -0.73	MIN.	0	210.760	3.0
			0.20	0.06	AS REQUIRED	Ž	Σ. N.	6	210-400	3.0
5/28-6/8	LASER PARAMETRICS DF/CO2		0.20	90.0	AS REQUIRED	•	ż	0-0.73	210.760	3.0
			0.20	90.0	AS REQUIRED	NF3-0.24 MIN.		NOM. 0.2	NOM. 0.2 360:540	

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